	Application No.	Applicant(s)
	10/775.042	SUNG, CHIEN-MIN
Notice of Allowability	Examiner	Art Unit
	Thu Khanh T. Nguyen	1722
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT F of the Office or upon petition by the applicant. See 37 CFR 1.31	pears on the cover sheet with S (OR REMAINS) CLOSED in the S) or other appropriate communi RIGHTS. This application is sub	the correspondence address nis application. If not included cation will be mailed in due course. THIS
1. ☑ This communication is responsive to <u>Amendment filed 1/2</u>	1	
2. The allowed claim(s) is/are <u>1-24</u> .	1	
 3. Acknowledgment is made of a claim for foreign priority to a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents 	ve been received. ve been received in Application l	No
International Bureau (PCT Rule 17.2(a)).		
* Certified copies not received:		
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONI THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	" of this communication to file a MENT of this application.	reply complying with the requirements
4. A SUBSTITUTE OATH OR DECLARATION must be subr INFORMAL PATENT APPLICATION (PTO-152) which gives	mitted. Note the attached EXAM ves reason(s) why the oath or do	INER'S AMENDMENT or NOTICE OF eclaration is deficient.
5. CORRECTED DRAWINGS (as "replacement sheets") mu	ust be submitted.	
(a) ☐ including changes required by the Notice of Draftsper		PTO-948) attached
1) hereto or 2) to Paper No./Mail Date		
(b) including changes required by the attached Examiner Paper No./Mail Date	r's Amendment / Comment or in	the Office action of
Identifying indicia such as the application number (see 37 CFR each sheet. Replacement sheet(s) should be labeled as such in	1.84(c)) should be written on the the header according to 37 CFR	drawings in the front (not the back) of 1.121(d).
6. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT	osit of BIOLOGICAL MATER FOR THE DEPOSIT OF BIOLO	IAL must be submitted. Note the OGICAL MATERIAL.
Attachment(s)	- 🗖	
1. Notice of References Cited (PTO-892)		mal Patent Application
2. Notice of Draftperson's Patent Drawing Review (PTO-948)		mary (PTO-413), ail Date
3. Information Disclosure Statements (PTO/SB/08), Paper No./Mail Date		nendment/Comment
4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	8. ⊠ Examiner's Sta 9. □ Other	atement of Reasons for Allowance
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EXAMINER'S AMENDMENT

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

The application has been amended as follows: In the specification, page 1, line 6, after "filed January 13, 2004" insert , now US Patent. No. 7,128,547.

- 2. Claims 1-24 are allowed over the prior art of record.
- 3. The following is an examiner's statement of reasons for allowance:

Davies (5,772,756) discloses an apparatus for producing diamond crystal growth on a seed crystal, comprises a plurality of walls forming a high pressure chamber, crystal diamond seeds, a metallic catalyst/solvent in communication with the seeds on one side and a layer of raw material such as carbon located adjacent to the catalyst layer and in communicate with the catalyst on the other side.

However, Davies fails to disclose a system in which the raw material layer is located inside the high pressure chamber in such a way that it diffuses into the catalyst layer in a direction that is perpendicular to gravity, in order to avoid detrimental effects of gravity on the molten catalyst and increase availability volumes for growing crystal inside the high pressure chamber, to reduce problems associated with differences in density and temperature gradients during diamond synthesis, and to increase diffusion of raw material by convection flow of molten material (see specification and Remark, pages 8-9).

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Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

4. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Thu Khanh T. Nguyen whose telephone number is 571-272-1136. The examiner can normally be reached on Monday- Friday, 7:30-5:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Gupta Yogendra can be reached on 571-272-1316. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

TN · 1/29/07

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SUPERVISORY PATENT EXAMINER
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